

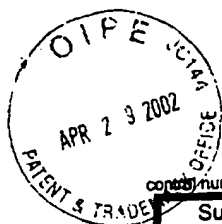
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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)

Sheet

1

of

1

Complete if Known

Application Number	09/997,553
Filing Date	11/29/2001
First Named Inventor	Lee et al.
Art Unit	3723
Examiner Name	Unknown
Attorney Docket Number	PA0371-US/11269.38

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Filing Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Title Of Patent Application
		Application Serial Number - Kind Code ² (if known)			
PK	AA	US- 09/919,940**	08-02-2001	Takahashi	Stage Unit, Measurement Unit and Measurement Method, and Exposure Apparatus and Exposure Method
PK	AB	US- 09/635,339	08-09-2000	Shiraishi et al.	Adjusting Method for Position Detecting Apparatus
		US-			
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	1
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
PK	AC	JP-2002-50560	02-15-2002			

** Please note that US Application Serial No. 09/919,940 is believed to be a counterpart application based on JP 2002-50560.

Examiner
Signature

[Handwritten Signature]

Date
Considered

8/29/03

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